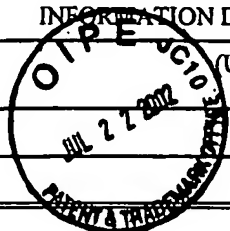


U.S. Department of Commerce, Patent and Trademark Office		Attorney Docket No.	10/085,951
		TT4274	10/085,867
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant(s)	
(Use several sheets if necessary)		Russell C. Brown, Donald C. Likes, David A. Richardson, Yurong Shi, Jeffrey B. Toth	
		Filing Date	Group
		February 28, 2002	2122



U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>Jan</i>	AA	6,334,122 B1	Dec. 25, 2001	Brown	707	2	Dec. 23, 1998
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Foreign Patent Documents

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	A						<input type="checkbox"/>	<input type="checkbox"/>
	AN						<input type="checkbox"/>	<input type="checkbox"/>
	AO							
	AP							

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Examiner *Klausen Anthony* Date Considered

3/4/05

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